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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent of:

Hirayama et al

U.S. Patent No.: 6,884,365

Issue Date: April 26, 2005

For: GAS FOR PLASMA REACTION AND METHOD FOR PRODUCTION THEREOF

SUBMISSION OF PUBLICATIONS UNDER 37 CFR § 1.501

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

May 17, 2005

Sir:

The undersigned herewith submits in the above-identified patent the following documents (including copies and English language abstracts thereof) which may be relevant to the patent:

<u>Document No.</u>	<u>By</u>	<u>Date</u>
L.T.M-E, EP 0913380	Nippon Zeon Co.	5/6/99
L.T.M-E, PCT WO98/19331	Nippon Zeon Co.	5/7/98
L.T.M-E, Supplemental EP Search Report		5/15/03

The documents are being submitted to be placed in the file wrapper of the subject patent.

Lynette T. Wang-Eurini

5/30/2005